

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants:	Yeo, <i>et al.</i>	Docket No.:	TSM03-0847
Serial No.:	10/826,602	Art Unit:	1795
Filed:	April 16, 2004	Examiner:	Raymond, Brittany L.
For:	Lithography Apparatus for Manufacture of Integrated Circuits		

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT ACCOMPANYING RCE**

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated October 2, 2007, which Action is made final, and the subsequent Advisory Action dated December 3, 2007. Applicants respectfully request that these amendments and remarks be entered pursuant to the provisions of 37 CFR § 1.114, and respectfully request reconsideration of the claims.